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NiCo₂O₄ thin film prepared by electrochemical deposition as a hole-transport layer for efficient inverted perovskite solar cells†

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Spinel NiCo₂O₄ is a promising p-type semiconductor for optoelectronic devices; however, it is difficult to prepare uniform and large-area NiCo₂O₄ films, which hinders its application as a hole transport material for perovskite solar cells (PSCs). In this study, a novel, mild, and low-cost KCl-assisted electrochemical deposition (ECD) approach was developed to directly prepare a uniform NiCo₂O₄ film on a fluorine-doped tin oxide (FTO) substrate. A uniform NiCo₂O₄ film prepared through an ECD approach was used as a hole-transport layer (HTL) in inverted PSCs. The resulting NiCo₂O₄ HTL-based device achieved a power conversion efficiency (PCE) of 19.24% with negligible hysteresis and excellent reproducibility. Additionally, it outperformed a NiO_x-based device (PCE = 18.68%). The unsealed devices retained 90.7% of their initial efficiency when subjected to stability measurements for 360 h in an ambient atmosphere. This study shows the great potential of ECD-prepared NiCo₂O₄ HTLs for large-area PSCs in the future.

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Introduction

Recently, organic-inorganic hybrid perovskite solar cells (PSCs) have attracted tremendous attention owing to their low cost and high power conversion efficiency (PCE).^{1–4} In a typical PSC structure, carrier-transport layers (CTLs) connected with perovskite materials could not only improve the charge transfer from the perovskite light absorption layer to the current-collecting electrode, but also block the injection of the opposite charge carrier.^{5,6} Meanwhile, the CTL can also act as a protective layer to prevent perovskite from exposure to water and oxygen. Therefore, a suitable CTL is crucial to improve the PCE and stability of PSCs.⁷

Numerous materials have been used as hole-transport layers (HTLs) for PSCs. However, most of the popular hole-transport materials (HTMs) used in conventional n-i-p type PSCs, such as 2,2,7,7-tetrakis(*N,N*-di-*p*-methoxyphenyl-amino)-9,9-spirobifluorene (spiro-OMeTAD), polytriarylamine (PTAA), and other molecules, are poor conductors which require extra chemical doping to offset their insufficient mobility and conductivity.^{8,9} This decreases the stability and increases costs, thereby hindering the commercial application of these

materials as HTLs in PSCs. In inverted-structured PSCs, poly(3,4-ethylenedioxythiophene):poly(styrenesulfonate) (PEDOT:PSS) is frequently employed as an organic HTL. PEDOT:PSS demonstrates excellent electrical conductivity and moderate processing, but its acidic, hydrophilic nature induces the degradation of the perovskite component and sequentially restricts its development as a superior HTL in solar cells.¹⁰ Generally, inorganic HTMs are low-cost and exhibit better physical and chemical stability than that of organic materials. Besides, they also have tunable optical and electrical properties, which made them promising HTLs.¹¹ Among them, NiO_x materials are one of the most commonly used inorganic HTMs in inverted PSCs. However, they have relatively low intrinsic conductivity, which needs to be addressed prior to their application.^{12–14} Ternary oxides are ideal replacements for NiO_x because of their respectable hole extraction and transporting abilities, good conductivity, and tunable optical properties. Early in 2016, Liao and Wang *et al.* reported a CuAlO₂ material prepared by magnetron sputtering method, which was employed as hole selective buffer layer in inverted planer PSCs and achieved a PCE of 14.5%.¹⁵ Later, solution-processed CuGaO₂ nanoplates were synthesized by a microwave-assisted hydrothermal method by Jen and Chen *et al.*, and the CuGaO₂ nanoplates were used as HTL in the n-i-p configuration PSCs with a promising PCE of 18.5% and improved ambient stability.¹⁶ Furthermore, a Cu₃Cr₂O₂ HTL synthesized by the sol-gel method was reported by Fang and Li *et al.*, and the resulting PSCs achieved a high PCE of 17.19% on glass and 15.53% on flexible PET substrates, which were much higher than mono-metal oxide-based devices.¹⁷

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NiCo₂O₄ is a p-type semiconductor with a cubic spinel structure, in which Ni ions occupy the octahedral sites while Co ions are distributed across both octahedral and tetrahedral sites.¹⁸ NiCo₂O₄ has the advantages of being abundant, relatively inexpensive, and environmentally friendly, making it a promising candidate for future commercialization. These properties are desirable for the use of NiCo₂O₄ in various electronic devices, such as supercapacitors,¹⁸ lithium-ion batteries,¹⁹ electrocatalysts for water splitting,²⁰ *etc.* Besides, NiCo₂O₄ has the highest conductivity (500 S cm⁻¹) among transparent conducting oxides, which is much higher compared to a NiO_x-based HTL.^{21,22} Additionally, NiCo₂O₄ possesses a wide optical bandgap and a deep valence band position, which matches well with the valence band (VB) of perovskite material, especially for CH₃NH₃PbI₃ (MAPbI₃).²³

In 2018, Choy *et al.* synthesized well-dispersed NiCo₂O₄ nanoparticles (NPs) through a controllable Co-NH₃ deamination reaction in a sol system containing Ni(OH)₂ and the resulting inverted-structured PSC based on this NiCo₂O₄ HTL yielded a PCE of 18.23% and exhibited high stability.²⁴ Same year, Choulis *et al.* applied combustion-synthesized ultrasmall NiCo₂O₄ NPs as HTL to form inverted-structure PSCs and achieved a PCE of 15.5%.²⁵ Recently, Jung *et al.* reported the conventional-structured PSCs fabricated with featured HTLs comprising sol-gel-driven NiCo₂O₄ and yielded PCEs of up to 18.16%.²³ Akhter *et al.* used NiCo₂O₄ NPs synthesized *via* a chemical co-precipitation method as HTLs in n-i-p type PSCs and achieved a PCE of >14%.²⁶ These work not only demonstrated that ternary oxide NiCo₂O₄ could be used as an HTL in PSCs, but also suggested a possible way to synthesize ultrasmall NPs even though the preparation methods for ultrafine NiCo₂O₄ NPs are energetically demanding, expensive, and time-consuming. Meanwhile, the above researches show that the spin-coating process is the most commonly adopted strategy for fabricating NiCo₂O₄ HTLs, but this method can be relatively inefficient regarding the reduction in the waste of materials. Therefore, an easy, low-cost, and controllable method for preparing compact and uniform NiCo₂O₄ HTLs is urgently needed.

As a mature and completely commercialized technology, electrochemical deposition (ECD) is often utilized to prepare nanomaterials on different conductive substrates. Owing to its low cost, low-temperature requirements, large-area production, and precise control, it can be controlled by regulating the deposition time, current, and/or voltage.²⁷⁻³¹ To ensure a good conductivity of the precursor solution, potassium chloride (KCl) is commonly introduced as a supporting electrolyte.³² In addition, because of the strong adsorption behavior of Cl⁻,^{33,34} KCl may play an additional role in the nanomaterials formation process *via* ECD technique. In this study, NiCo₂O₄ films were prepared *via* a KCl-assisted ECD process to construct HTLs for the first time for MAPbI₃-based inverted-structure PSCs (Scheme 1). The aim of this study was to explore the potential of ECD-prepared NiCo₂O₄ HTLs for PSCs, and to provide a new perspective on the preparation of advanced HTLs for further enhancement of the PCEs of PSCs *via* ECD methods.

Experimental

Synthesis of NiCo₂O₄ and NiO_x films

Patterned fluorine-doped tin oxide (FTO)/glass substrates were successively cleaned in a detergent solution, deionized water, acetone, and isopropanol for 30 min with ultrasonic treatment, respectively. Before using, all substrates were treated with ultraviolet ozone for 20 min. The ECD processes for NiCo₂O₄ or NiO_x were carried out with a three-electrode system, where the cleaned FTO glass functioned as the working electrode, a Pt foil was used as the counter electrode, and the reference electrode comprised saturated Ag/AgCl. Three kinds of electrolytes containing 20 mM Co(NO₃)₂·6H₂O, 10 mM Ni(NO₃)₂·6H₂O and different concentrations of KCl (0, 50, and 100 mM) were used, thus the stoichiometric Ni : Co : K ratios for these different electrolytes were 1 : 2 : 0, 1 : 2 : 5, and 1 : 2 : 10, respectively. After the NiCo₂O₄ precursors were deposited on the surface of each FTO glass substrate, the films were annealed in a furnace at 300 °C for 2 h in air. The resulting samples are denoted herein as NiCo₂O₄ (0-NiCo₂O₄, 5-NiCo₂O₄, and 10-NiCo₂O₄, respectively). For comparison, 30 mM Ni(NO₃)₂ in water was selected as the deposition solution for the preparation of NiO_x. The ECD process was carried out by a chronopotentiometry method with a current density of 0.3 mA cm⁻². The as-deposited film was then rinsed with deionized water before being annealed in a tube furnace at 300 °C for 1 h.

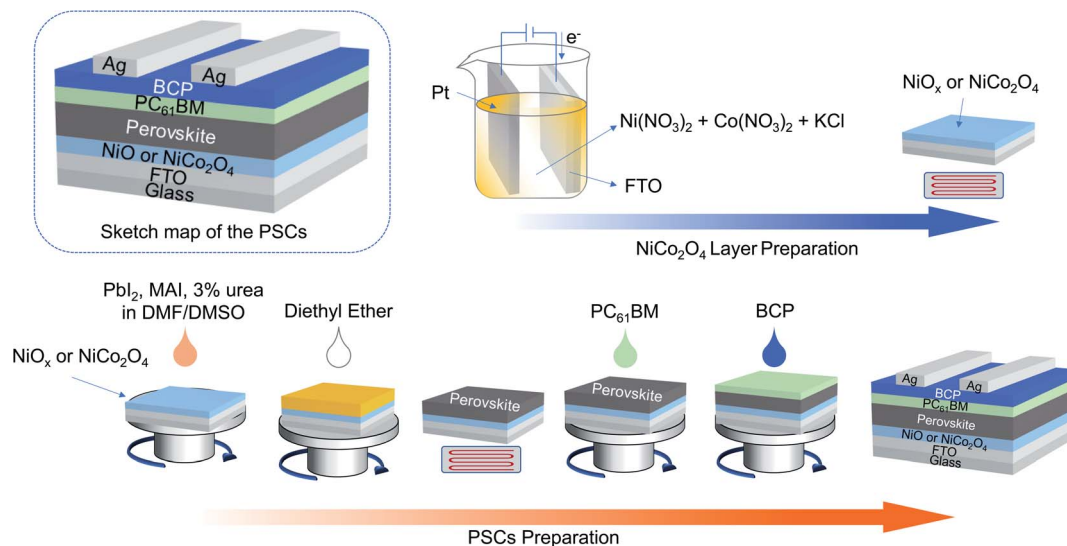
Device fabrication

PbI₂ (461 mg) and CH₃NH₃I (MAI, 159 mg) were first dissolved in anhydrous dimethylformamide (DMF, 634 μL) and anhydrous dimethyl sulfoxide (DMSO, 70.9 μL), respectively. Then, 3 mol% urea (*versus* PbI₂ or MAI) was added to the solution, and the mixture was then magnetically stirred for 3 h at room temperature in a nitrogen-filled glovebox. The NiCo₂O₄ and NiO_x films were then transported to the glovebox for the preparation of perovskite films, which was conducted through a one-step antisolvent-assisted procedure.³⁵ The precursor solution was spin-coated onto NiO_x or NiCo₂O₄ coated FTO at 1000 rpm for 10 s, and 4000 rpm for 30 s in sequence. Then, 200 μL diethyl ether was quickly dripped onto the film at the high-speed step. The resulting film was heated at 65 °C for 1 min, and then at 100 °C for 10 min. Subsequently, a layer of [6,6]-phenyl-C61-butyric acid methyl ester (PC₆₁BM; 20 mg mL⁻¹ in chlorobenzene) was spin-coated onto the perovskite layer at 1500 rpm for 30 s, following which a thin layer of bathocuproine (BCP; 0.5 mg mL⁻¹ in isopropanol) was deposited on top of the PC₆₁BM layer at 5000 rpm for 30 s. Finally, Ag film with 100 nm thickness was thermally evaporated under vacuum (<5 × 10⁻⁴ Pa) to form the contact electrode.

Characterizations

The *J-V* curves of the prepared devices were measured under standard 1 sun, AM 1.5 G conditions, with a solar simulator (Newport 94023A, USA), with 0.1 V s⁻¹. The electrochemical impedance spectroscopy (EIS) was performed in the dark at





Scheme 1 Schematic illustrations of NiCo_2O_4 film fabrication process, prepared *via* electrochemical deposition, and of perovskite solar cell (PSC) preparation procedure. FTO: fluorine-doped tin oxide, DMF: dimethylformamide, DMSO: dimethyl sulfoxide.

a potential of 1.0 V, the frequency was swept from 0.1 Hz to 1 MHz using an electrochemical workstation (Zennium X, Zahner), and the oscillation potential amplitude was adjusted to 10 mV. The crystal structure of NiO_x or NiCo_2O_4 film was by X-ray diffraction (XRD, 9 kW, SmartLab). The elemental composition and the energy level of NiCo_2O_4 film were characterized by X-ray photoelectron spectroscopy (XPS, ESCALAB XI⁺, Thermo Fisher Scientific) and ultraviolet photoelectron spectroscopy (UPS) with a monochromatic He-I light source with an incident energy of 21.22 eV. The morphology of samples was examined by scanning electron microscopy (SEM, SU8220, Hitachi). Optical transmission spectroscopy of NiO_x or NiCo_2O_4 film were collected by UV-visible spectrophotometer (Agilent 8453). The electrical performance of NiO_x or NiCo_2O_4 film was analyzed by a Hall-effect system (8400, Lake Shore).

crystallized NiCo_2O_4 films were obtained *via* ECD method with/without KCl additive.

Optical transmission spectra were conducted to characterize the optical properties of prepared NiO_x and NiCo_2O_4 films deposited on the FTO/glass substrate. As shown in Fig. 1b, all samples exhibited almost the same transmission properties as the bare FTO/glass substrate, which maintained a high transmittance (>75% across the spectral range of 400–850 nm). The high transparency of the prepared HTLs minimized the optical losses of the photovoltaic devices and exhibited no competition with the light absorption layer perovskite, thereby ensuring considerable photon-generated carriers. In addition, the optical bandgap of the NiCo_2O_4 material was estimated to be 1.88 eV

Results and discussion

As shown in Scheme 1, the NiCo_2O_4 precursor was prepared by chronopotentiometry with a current density of 0.3 mA cm^{-2} for a range of different times. In the inverted-structured PSCs, the perovskite layer based on the as-prepared NiCo_2O_4 HTLs was constructed by a one-step antisolvent-assisted procedure, in which a spin-coated PC_{61}BM layer was used as the ETL and Ag was used as the counter electrode.

XRD was used to characterize the crystal structures of the NiCo_2O_4 series films on each FTO/glass substrate. As shown in Fig. 1a, the diffraction peaks of the FTO/glass substrate could be detected in all of the XRD patterns of the samples, owing to the ultrathin thickness of the electrodeposited films. In addition to the strong base peaks, three weak diffraction peaks located at 18.9° , 31.1° , and 36.6° were observed, which could be assigned as (111), (220), and (311) crystal planes respectively of the standard patterns of the cubic spinel NiCo_2O_4 crystalline phase (JCPDF#73-1072). The XRD results demonstrated that well-

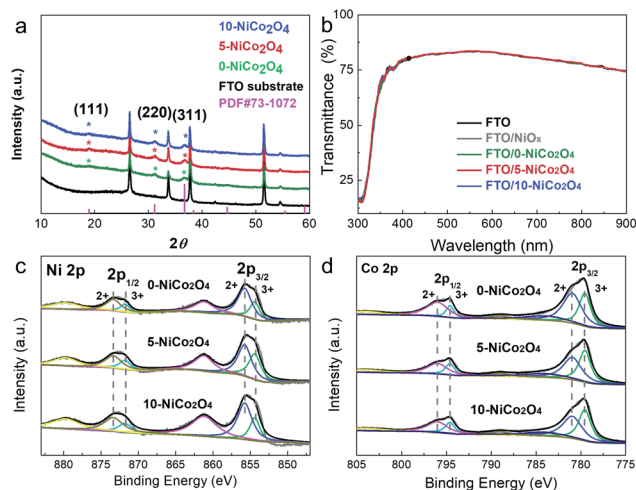


Fig. 1 (a) XRD patterns of NiCo_2O_4 films deposited on FTO/glass substrates, (b) optical transmission spectra of NiO_x and different NiCo_2O_4 films, and XPS spectra of (c) Ni 2p and (d) Co 2p for the NiCo_2O_4 films.



from the Tauc plot (Fig. S1[†]), which is slightly lower than the previously reported value for NiCo₂O₄ NPs.²⁴

To further analyze the elemental composition and chemical bonding states of NiCo₂O₄ films, XPS measurements were performed. The high-resolution XPS Ni 2p spectrum could be fitted to two spin-orbit doublets and two shakeup satellites (Fig. 1c). The well-fitted peaks at 855.8 eV (2p_{3/2}) and 873.4 eV (2p_{1/2}) were attributed to the characteristic peaks of the Ni²⁺ oxidation state, and the binding energies of 854.4 eV and 871.8 eV were indexed to Ni³⁺.²⁴ According to this, the ratio of Ni³⁺/Ni²⁺ for 0-NiCo₂O₄, 5-NiCo₂O₄ and 10-NiCo₂O₄ was 0.43, 0.66, and 0.44, respectively, suggesting that optimized KCl additive concentration in deposition precursors was beneficial for the presence of Ni³⁺ state. Additionally, the presence of the Ni³⁺ state could have induced oxygen deficiency in the lattices, and further facilitated the generation of holes in the materials.²³ Besides, the relatively high Ni³⁺/Ni²⁺ ratios on the surfaces of the NiCo₂O₄ films rendered a p-type semiconducting property to the material and increased conductivity, thereby promoting more efficient charge separation and transport.^{36,37} For Co 2p, the binding energies of 796.0 eV and 781.0 eV were indexed to Co²⁺, while the peaks of 794.6 eV and 779.5 eV were associated with Co³⁺ (Fig. 1d). The obtained binding energies of Ni 2p and Co 2p were consistent with previously reported values,^{24,38} and no differences were found between the 0-NiCo₂O₄, 5-NiCo₂O₄, and 10-NiCo₂O₄ films.

The morphologies of the NiO_x and NiCo₂O₄ films were investigated through SEM characterization. As shown in Fig. 2a, the as-formed NiO_x film had an extremely tiny fluffy porous structure and fully covered the FTO substrate. However, the 0-NiCo₂O₄ film had a messy porous structure with numerous intersecting nanosheets (Fig. 2b), resulting in plenty of pinholes and open space sites in the HTL films, which could not ensure complete contact at the HTL/perovskite interface.

Fig. 2c and d illustrate the influence of the KCl additives on the surface morphology of the NiCo₂O₄ films. When KCl was added to the deposition solutions, the NiCo₂O₄ layers retained

their pristine surface morphology covered on the FTO/glass substrates, which is beneficial for the adhesion of perovskite materials on the HTLs. And on this basis, the film quality of the resulting 5-NiCo₂O₄ films has been obviously improved, such as larger grain size and better coverage as well as improved compact nanocrystals quality in comparison with NiO_x film (Fig. 2d). These improvements could be mainly attributed to the assistance of KCl in the previous report,³³ which could further promote interface charge extraction and separation.

UPS measurements were performed to investigate the energy levels of the as-prepared NiCo₂O₄ films. Relative to the vacuum level, UPS revealed the valence band maximum (VBM) levels to be -4.99 eV, -4.94 eV and -4.79 eV for 0-NiCo₂O₄, 5-NiCo₂O₄ and 10-NiCo₂O₄, respectively (Fig. S2[†]). The corresponding energy diagram of a PSC based on the prepared NiCo₂O₄ HTL is illustrated in Fig. 3a. The VBM levels of samples 0-NiCo₂O₄ and 5-NiCo₂O₄ were clearly closer to that of MAPbI₃ (-5.4 eV), indicating that their energy level matched with that of MAPbI₃ very well when acting as HTLs, and would thus ensure efficient hole extraction at the corresponding interfaces. Furthermore, the electrical properties of the NiO_x and NiCo₂O₄ layers were evaluated by Hall-effect measurements (Fig. 3b). The electrical conductivity and hole mobility of the NiCo₂O₄ films was almost two orders of magnitude higher than those of the NiO_x film, demonstrating the superior charge transport properties of the NiCo₂O₄ films. Notably, the 5-NiCo₂O₄ film possessed the highest conductivity and hole mobility among all the NiCo₂O₄ films. The observed differences in VBM levels and electrical properties of NiCo₂O₄ may be attributed to the highest ratio of self-doping created by introducing most Ni³⁺ into the NiCo₂O₄ crystal lattice *via* appropriate KCl concentration,^{12,39} as discussed in the XPS analysis above.

As shown in Fig. S3,[†] all of the perovskite films based on the NiO_x and NiCo₂O₄ layers exhibited identical crystal structures and similar crystallinities. The main diffraction peaks at 14.16°,

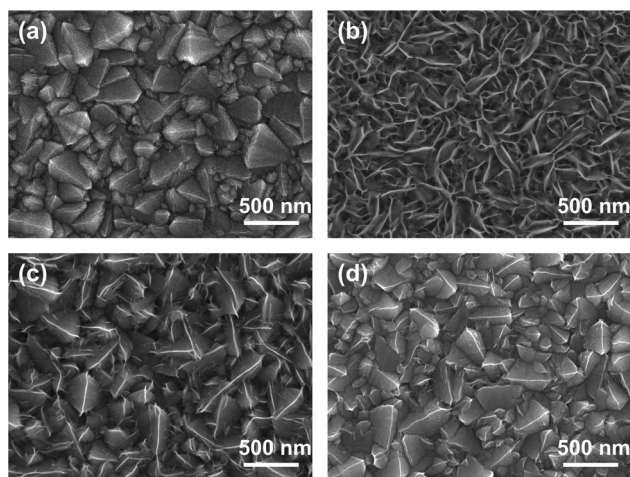


Fig. 2 Top-view SEM images of (a) NiO_x film, and (b) 0-NiCo₂O₄, (c) 5-NiCo₂O₄, and (d) 10-NiCo₂O₄ films deposited on FTO substrates.

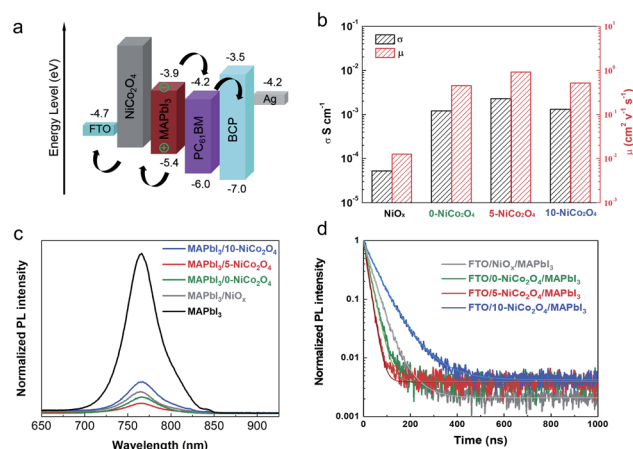


Fig. 3 (a) Energy band diagram relative to a vacuum level of the device. (BCP: bathocuproine) (b) Hall-effect measurements of NiO_x and NiCo₂O₄ films. (c) Steady-state photoluminescence of MAPbI₃ based on NiO_x and NiCo₂O₄ films. (d) Time-resolved photoluminescence spectra of the perovskite films on NiO_x and NiCo₂O₄ HTLs.



28.78°, and 31.92° corresponded to the (110), (220), and (310) crystal planes of the perovskite (MAPbI₃), respectively. No impurity peaks were observed, except for one weak peak located at 12.6° which was indexed to traces of excess PbI₂. The strongest peak intensity of perovskite/5-NiCo₂O₄ suggested the best perovskite crystallinity on the 5-NiCo₂O₄ layer, while a similar phenomenon could be convinced by the top-view SEM images as shown in Fig. S4.† Less and smaller cracks appear in the NiCo₂O₄ supported perovskite layer. Especially for the perovskite/5-NiCo₂O₄ film, smooth and dense film morphologies were displayed with full surface coverage. These comparably high-quality films could directly influence solar cell performance. It can be seen from the UV-vis spectroscopy that the perovskite films based on NiO_x and different NiCo₂O₄ HTLs exhibit similar absorption over the entire visible region (Fig. S5†).

The charge transfer dynamics of perovskite films deposited on NiO_x or NiCo₂O₄ were studied *via* steady-state photoluminescence (PL) and time-resolved photoluminescence (TRPL) measurements with excitation at 550 nm. As shown in Fig. 3c, the highest PL intensity was observed for the bare MAPbI₃ film. After the introduction of the HTLs, the PL intensity decreased drastically, following the order of: MAPbI₃/10-NiCo₂O₄ > MAPbI₃/NiO_x > MAPbI₃/0-NiCo₂O₄ > MAPbI₃/5-NiCo₂O₄. MAPbI₃/5-NiCo₂O₄ exhibited the highest degree of PL quenching, which means it achieved the best hole extraction and transport efficiency from perovskite to the HTL. This finding agrees well with its suitable energy level alignment and outstanding electrical properties, as discussed above. Fig. 3d shows the TRPL spectra of MAPbI₃ films deposited on different HTLs. The PL decay curves have been fitted using a bi-exponential decay function as following eqn (1) and the corresponding parameters are summarized in Table S1.†

$$f(t) = A_1 \exp(-t/\tau_1) + A_2 \exp(-t/\tau_2) + B \quad (1)$$

where the fast component τ_1 is ascribed to the charge extraction at the HTL/perovskite interface, while the slow component τ_2 is related to the bimolecular recombination process in bulk perovskite film.⁴⁰ A_1 and A_2 represent the contribution proportion of fast and slow component, respectively. Table S1† shows the corresponding parameters of the TRPL spectroscopy. The decrease of fast component τ_1 indicated the faster hole transfer from perovskite to HTL. The high proportion of τ_1 indicated that charge extraction at the HTL/perovskite interface is dominant in the PL quenching process rather than undergoing the bimolecular recombination in bulk perovskite. These results are in good agreement with recently reported results that the bimolecular recombination in perovskite film is negligible at a low light intensity, and it begins to dominate only when the light intensity is around 100 suns.⁴¹ The MAPbI₃ film on NiO_x substrate exhibited the average decay time (τ_{ave}) of 42.63 ns for photogenerated excitons, whereas the perovskite films deposited on 0-NiCo₂O₄, 5-NiCo₂O₄ and 10-NiCo₂O₄ HTLs showed the τ_{ave} of 34.34, 31.74 and 64.68 ns, respectively. The rapid decay of PL is evidence of efficient hole extraction at the interface

between perovskite and HTL, which is in good agreement with the steady-state PL results.

To probe the effect of NiCo₂O₄ film as HTL on device performance, we firstly fabricated the inverted-structure PSCs (FTO/NiCo₂O₄/MAPbI₃/PC₆₁BM/BCP/Ag) with different thicknesses of 0-NiCo₂O₄ film (different deposition charge density) by a one-step antisolvent-assisted procedure. Fig. S6a† shows the J - V characteristic curves for the respective champion device, and the corresponding device parameters are summarized in Table S2.† Obviously, with the increase of deposition charge density for NiCo₂O₄ film, the device performance presented a tendency to increase first and then decrease. The thinner NiCo₂O₄ layer-based PSC (5 mC cm⁻²) displayed a inferior performance with a low current density. This can be attributed to the current leakage resulting from incomplete coverage of NiCo₂O₄ on FTO substrate. Meanwhile, the thicker NiCo₂O₄ layer-based PSC (20 mC cm⁻²) was also subjected to a poor current density due to the increase of series resistance (R_s). And the optimum thickness of NiCo₂O₄ layer was found to be a charge density of 10 mC cm⁻², which resulted in a PCE of 18.66% with J_{sc} of 22.93 mA cm⁻², V_{oc} of 1.02 V, and fill factor (FF) of 0.78. The results were further confirmed by the efficiency distributions as a function of deposition charge density, as shown in Fig. S6b.†

We further fabricated the inverted PSCs based on NiO_x and different NiCo₂O₄ HTLs at the charge density of 10 mC cm⁻², the J - V characteristic curves of the respective champion devices are shown in Fig. 4a, and the corresponding photovoltaic parameters are summarized in Table 1. The J - V curves of champion devices based on NiO_x and 0-NiCo₂O₄ HTLs almost overlapped. Among all the devices, the 5-NiCo₂O₄ HTL-based device displayed the highest PCE of 19.24%,

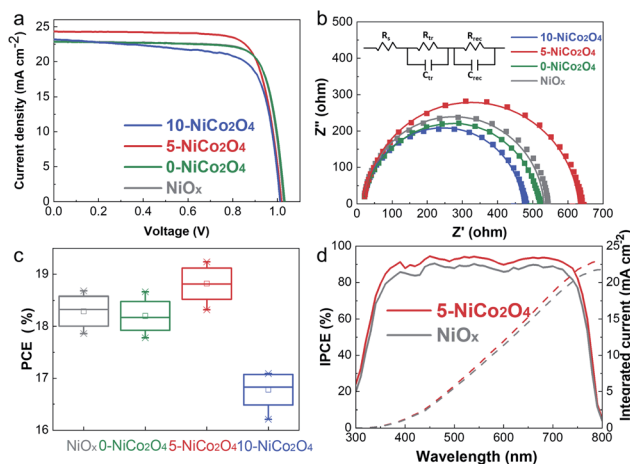


Fig. 4 (a) J - V characteristics of best NiO_x and NiCo₂O₄-based PSCs measured under illumination (1 sun). (b) Nyquist plots of PSCs based on NiO_x and NiCo₂O₄ HTLs for electrochemical impedance spectroscopy (EIS) experiments. Solid lines show fitting curves. (c) Statistics of ten pieces of each PSCs based on NiO_x and NiCo₂O₄ HTLs. (d) Incident-photon-to-current efficiencies (IPCEs) of PSCs based on NiO_x and 5-NiCo₂O₄ HTLs under monochromatic light with varying wavelengths. Dashed lines represent corresponding integrating currents over AM 1.5 G solar irradiance spectra.



Table 1 Photovoltaic parameters of PSCs based on NiO_x and NiCo₂O₄ HTLs under the illumination

HTL	V_{oc} (V)	J_{sc} (mA cm ⁻²)	FF (%)	PCE (%)
NiO _x	1.03	22.86	79.61	18.69
0-NiCo ₂ O ₄	1.03	22.84	79.31	18.66
5-NiCo ₂ O ₄	1.02	24.31	77.89	19.24
10-NiCo ₂ O ₄	1.01	23.14	73.09	17.09

a short-circuit current density (J_{sc}) of 24.31 mA cm⁻², a fill factor (FF) of 0.78, and an open-circuit voltage (V_{oc}) of 1.02 V. The J_{sc} of the 5-NiCo₂O₄ HTL-based device improved from 22.83 to 24.31 mA cm⁻² compared with that of the 0-NiCo₂O₄ based device, which can be attributed to the smoothest surface morphology of 5-NiCo₂O₄ and complete contact with the perovskite layer, as well as best hole extraction ability, hole mobility and conductivity. The 10-NiCo₂O₄ HTL-based device delivered a poor efficiency with a low V_{oc} and FF, owing to its mismatched energy level compared to the perovskite layer. Furthermore, Fig. 4c provides statistical data regarding the reproducibility of the performances of the NiO_x- and NiCo₂O₄-based PSCs. These results are in good agreement with the statistical efficiency distributions of the different devices. The average PCE for the NiO_x HTL-based devices obtained from the ten devices was 18.17 ± 0.32%; this increased to 18.94 ± 0.29% for 5-NiCo₂O₄. The photovoltaic performance disadvantage of NiCo₂O₄-based devices is the relatively low open-circuit voltage (V_{oc}), resulting from the nonradiative recombination losses at the HTL/perovskite interface. To address this issue, it is necessary to minimize the energy barrier at the interface. Small organic molecules with high electron affinity, such as F4TCNQ, could shift the Fermi level of HTMs toward the VBM of perovskite, which is a feasible strategy to reduce the interfacial energy barrier and strengthen the p-type property of HTM. This research on boosting the open-circuit voltage will continue to be discussed in future work.

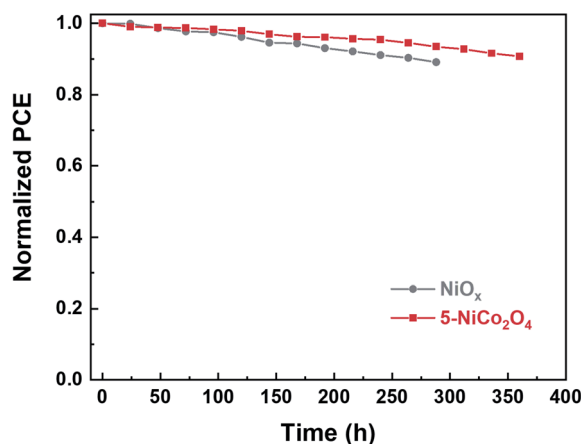
EIS measurements were performed to give a closer inspection of the charge transport process and recombination process at the interfaces.¹⁴ As shown in Fig. 4b, only one semicircle was observed for each sample, which corresponds to the recombination resistance (R_{rec}). The largest semicircle belonged to the 5-NiCo₂O₄ HTL-based device, which revealed that the carrier recombination at the interfaces between the HTL and perovskite layer was retarded. The semicircle of the NiO_x device was slightly larger than that of the 0-NiCo₂O₄-based device, corresponding to the photovoltaic performances of the two devices (Fig. 4a and Table 1). The lowest R_{rec} was obtained for the 10-NiCo₂O₄ based device, which correlated well with the observed decreases in V_{oc} and FF. As discussed above, the 5-NiCo₂O₄ HTL-based PSC had the lowest interfacial recombination loss, which was beneficial for faster charge transfer and collection across the device, thus resulting in a higher PEC. Besides, we measured the dark J - V curves of PSCs incorporated with NiO_x and different NiCo₂O₄ HTLs, as depicted in Fig. S7.† The dark current

density decreases in the order of 10-NiCo₂O₄ > NiO_x > 0-NiCo₂O₄ > 5-NiCo₂O₄, indicating that 5-NiCo₂O₄-based device possesses better diode behavior with lower leakage current density.

As photocurrent hysteresis was a major issue in the accurate characterization of device efficiency, the typical J - V curves were measured for PSCs based on the NiO_x and 5-NiCo₂O₄ HTLs, with both reverse and forward scan directions (Fig. S8a†). The 5-NiCo₂O₄ HTL-based PSCs exhibited slight hysteresis in the J - V curves, and the reverse and forward scanning directions yielded PCEs of 19.73 and 19.24%, respectively (a difference of 0.49%, as listed in Table S4†). Meanwhile, the steady-state power output at the maximum power point for the optimized devices was recorded in Fig. S8b,† where the PCE of the 5-NiCo₂O₄ HTL-based PSC rose directly to a steady-state, yielding a maximum PCE value of 19.37% at 0.87 V. Low hysteresis and the quick photoelectric response could be attributed to the efficient charge separation and transport promoted by 5-NiCo₂O₄, which significantly suppressed interfacial charge recombination between the HTL and perovskite.¹⁶

The incident-photon-to-current efficiencies (IPCEs) of PSCs based on NiO_x and 5-NiCo₂O₄ HTLs were measured (Fig. 4d). As the wavelength was gradually increased from 300 to 800 nm, the IPCE of the PSC based on the 5-NiCo₂O₄ HTL remained higher than that of the NiO_x HTL-based PSC. Moreover, photocurrents of 22.98 mA cm⁻² and 21.78 mA cm⁻² were obtained by integrating the IPCE curves for PSCs based on 5-NiCo₂O₄ and NiO_x HTLs over the AM 1.5 G solar irradiation spectrum. These values are consistent with the experimentally measured J_{sc} values.

The long-term stabilities of unencapsulated PSCs based on the 5-NiCo₂O₄ and NiO_x HTLs were investigated in an ambient atmosphere at room temperature with humidity of 30–40% (Fig. 5). As the aging time was extended to approximately 360 h, the PCEs of the device fabricated on the 5-NiCo₂O₄ HTL remained at 90.7% of the initial efficiency. As a comparison, the PCE of the device based on NiO_x HTL retained less than 90% of its initial efficiency after only 288 h aging time under the same condition.

**Fig. 5** Long-term stability of the devices based on NiO_x and 5-NiCo₂O₄ HTLs stored at ambient conditions with humidity of 30–40%.

Conclusions

For the first time, NiCo₂O₄ films obtained by ECD method were employed as HTLs to obtain efficient and stable PSCs. Notably, when a suitable amount of KCl additive was added to the deposition solution, a smooth and compact NiCo₂O₄ layer could be obtained, which was beneficial for the contact of the perovskite layer covered on the NiCo₂O₄ HTL. Meanwhile, the p-type semiconductor property and electrical conductivity could both be enhanced, leading to efficient charge separation and transport between perovskite and the NiCo₂O₄ HTL. Thus, a PCE of 19.24% was obtained for the NiCo₂O₄ HTL-based champion device, with negligible hysteresis, excellent reproducibility, and long-term stability. In addition, this PCE was better than that of a NiO_x HTL-based PSC (18.68%). This study shows the huge potential of ECD-prepared NiCo₂O₄ HTLs for PSCs, and the findings presented here could provide a novel perspective on the preparation of advanced HTLs for further enhancement of PSCs performance and large-scale application.

Conflicts of interest

There are no conflicts of interest to declare.

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